

# 10µm Global Shutter Pixel for Radiation Tolerant CMOS Image Sensors

**Presenter**: Pedro Sants **Authors**: P. Santos, I. Hafizh, P. Leroux, G. Meynants 20/11/2024



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### Agenda

- Motivation and Global Shutter operation introduction;
- CDS in Image Sensors;
- Radiation Effects on MOSFET devices;
- CMOS Radiation tolerant techniques;
- 10µm Global Shutter CMOS Radiation Tolerant Pixel;
- Experimental Results;
- Conclusions;
- Q&A



# Rolling Shutter vs Global Shutter pixels



#### **Rolling shutter**



#### Challenges:

- Motion artifacts skew
- Speed limitation



#### **Readout at higher speed**



#### 4x lower skew but:

- 4x less signal per exposure
- No synchronization -> Flash





## Rolling Shutter vs Global Shutter pixels

#### **Global Shutter**





#### **Applications:**

- Snapshot and short exposure time;
- Structured light projection => depth;
- Background subtraction;

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### CDS in image sensors

- Cancels or reduces some noise (kTC, 1/f and offset).
- Pixel reset and pixel signal are stored;
- Difference is computed the result is the elective number of generated e-;
- Extracts the background noise from the radiation sources;
- CDS can either be analogue, digital or both processes combined.





# Radiation effects in MOSFETs





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### **CMOS** devices under radiation

• RHBD FET designs to mitigate the TID effects





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### 10µm Global shutter pixel design

b)





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VDD<sub>PIX</sub> VDD<sub>PIX</sub> **VDD**<sub>PIX</sub> output bus Ss RST SF2 SELs **∔**C<sub>s</sub> SF1 SEL<sub>R</sub> I<sub>Load-R</sub>O Column **VDD**<sub>PIX</sub> S<sub>R</sub> ≐ PC-SF3 SELR CR **ØI**Load-S

Voltage Domain Global Shutter Pixel: a) Schematic and b) Layout

# **Experimental Results**



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### **Experimental results**



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## Experimental results (2)







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#### **Pixel Performance**



Parameter	Pre-Rad	1 MGy + HTA	Unit
Conversion Gain (K)	5,034	4,13	μV/e-
Dark Current <sup>1</sup>	57,5	286,6	e-/s
Dynamic Range	49,3	43,4	dB
Temporal Dark noise	59,6	74,2	e-
FWC	17444	10981	e-

<sup>1</sup>at room temperature – 20C





### Conclusion



- The presented Voltage Domain Pixel design can withstand TID effects up to 1MGy (SiO<sub>2</sub>).
- The noise performance is yet to be improved;
- Dark current increases but is significantly mitigated by the RHBD techniques implemented;
- Pixel timing optimisation yet to be concluded;
- Integrated electronics (RHBD ADC's and readout electronics) can improve even further the pixel performance.
- Charge Domain Pixel designs suffer from the same issues, being expected similar degradation;



#### References



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Thank you



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